

IN THE UNITED STATES PATENT AND TRADEMARK OFFICERECEIVED  
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Applicant(s): Woo Sik Yoo  
 Assignee: WaferMasters, Inc.  
 Title: METHOD OF FORMING AN OXIDE LAYER (As Amended)  
 Serial No.: 10/085,498  
 Examiner: Jolley, Kirsten  
 Docket No.: M-11549 US

JUL 07 2004

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Group Art Unit: 1762**OFFICIAL**Irvine, California  
July 7, 2004

COMMISSIONER FOR PATENTS  
 P.O. Box 1450  
 Alexandria, VA 22213-1450

**PETITION FOR EXTENSION OF TIME**

Dear Sir:

Applicant(s) respectfully petition(s) for a 1-month extension of time within which to respond to the Final Office Action mailed by the U.S. Patent and Trademark Office on April 6, 2004, such extension allowing the undersigned until August 6, 2004 to respond.

Please charge the fee of \$55.00 to the undersigned's Deposit Account No. 50-2257.  
 Please charge any additional fees or credit overpayment to the above-deposit account. If there are any questions, please call the undersigned at (949) 752-7040.

I hereby certify that this correspondence is being sent by facsimile to (703) 872-9306, on July 7, 2004.

*Tina Kavanagh*  
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July 7, 2004

Respectfully submitted,

*David S. Park*  
David S. Park

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